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				Application Number	10/566,476-Conf. #5098	
INFORMATION DISCLOSURE				Filling Date	January 31, 2006	
STATEMENT BY APPLICANT			PPLICANT	First Named Inventor	Kazuhiro MURATA	
				Art Unit	1791	
(Use as many sheets as necessary)			ecessary)	Examiner Name	N. Sultana	
Sheet	1	of	1	Attorney Docket Number	0234-0507PUS1	

			U.S. PA	TENT DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number Numbes-Kind Code ^{2 (if known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

		FORE	GN PATENT	DOCUMENTS		
Examiner Indials*	Cite No.	Foreign Patent Document Country Code ³ (Number "Kind Code ³ (Number)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Clied Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Egures Appeor	r
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Include name of the author (in CAPTIAL EETTERS), tills of the article (when appropriate), tills of the steen (book, magazine, pursal, serial, symposium, catalog, etc.), dain, pagy(s), volume-issue number(s), publisher, orly and/or country where published. Kazulniro Murata, "Super-fine Init-jet printing for nanotechnology," Proceedings of the International Conference on MEMS, NANO and Smart Systems, pages 346-349, IEEE	T
	-
Computer Society, July 23, 2003	
_	omputer Society, July 25, 2003

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